

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Fang Docket No.: 01P14755 US
Serial No.: 09/941,963 Art Unit: 2823
Filed: August 28, 2001 Examiner: Lee, Hsien Ming
Title: Method of Cleaning an Inter-Level Dielectric Interconnect

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Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's Office Action mailed May 4, 2004. Please amend the above-referenced application as follows.

This amendment does not raise any new issues.